



Patent Docket  
LA-6762-102XX/09907997

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*5/A*  
*BAI-9-04*

In re the Application of:

SYWE N. LEE

Serial No.: 09/433,677

Filed: November 4, 1999

For: INTERLACE OVERLAP PIXEL  
DESIGN FOR HIGH SENSITIVITY  
CMOS IMAGE SENSORS

Group Art Unit: 2612

Examiner: Moe, Aung Soe

**RECEIVED**

JAN 07 2004

Technology Center 2600

**AMENDMENT AND RESPONSE**

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby submits this amendment in response to the Office Action mailed

*1/9/04*  
*WJL* July 2, 2003.

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